

FORM PTO-1449 (REV.7-80)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 854063.665	APPLICATION NO. 10/037,485
O INFORMATION DISCLOSURE STATEMENT <i>(Use several sheets if necessary)</i>		APPLICANT Ubaldo Mastromatteo	
		FILING DATE December 19, 2001	GROUP ART UNIT 2811

MAY 17 2002

U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
VM	AA 3,254,389	06/07/66	Andres et al.	29	25.3	-
VM	AB 5,406,701	04/18/95	Pepe et al.	29	840	-
VM	AC 5,627,106	05/06/97	Hsu	438	459	-
VM	AD 5,756,395	05/26/98	Rostoker et al.	438	622	-
VM	AE 5,858,814	01/12/99	Goossen et al.	438	107	-
VM	AF					
VM	AG					
VM	AH					
VM	AI					
VM	AJ					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO
VM	AK 0 993 034 A2	04/12/00	EP	
VM	AL			
VM	AM			
VM	AN			
VM	AO			

OTHER PRIOR ART *(Including Author, Title, Date, Pertinent Pages, Etc.)*

VM	AP	Ismail, M.S. et al., "Platinum Silicide Fusion Bonding," <i>Electronic Letters</i> , 27(13):1153-1155, June 20, 1991.
VM	AQ	Fukuroda, A. et al., "Si Wafer Bonding with Ta Silicide Formation," <i>Japanese Journal of Applied Physics</i> , 30(10A):L1693-L1695, October 1991.
VM	AR	Chaput, M., "Aligning Wafer Stacks with Machine Vision," <i>Global Semiconductor, Imaging Technology Incorporated</i> , no date, 1 page.

EXAMINER	HUNG K. VO	DATE CONSIDERED	11/18/02
----------	------------	-----------------	----------

* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).